



520.39737X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. OTSUBO EXPEDITED PROCEDURE
Serial No.: 09/842,000 BOX AF
Filed: April 26, 2001
For: PLASMA PROCESSING APPARATUS AND PROCESSING METHOD
Group: 1763
Examiner: A. Crowell

AMENDMENT AFTER FINAL ACTION

Mail Stop: Box AF Amendment (Fee)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 15, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the office action dated November 23, 2004, as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.